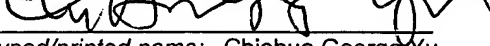


Attorney Docket: ATO-001.00

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Date: May 16, 2005

Signature: 
Typed/printed name: Chiahua George Yu

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re application of inventor(s): LIM, Brian Y. et al.

Serial No.: 10/613,513

Filed: July 3, 2003

Title: APPARATUS AND METHOD FOR FABRICATION OF NANOSTRUCTURES
USING MULTIPLE PRONGS OF RADIATING ENERGY

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is:

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- [] * believed to be being submitted under 37 CFR §1.97(b)(3) (before the mailing of a first Office action on the merits) or 37 CFR §1.97(b)(4) (before the mailing of a first Office action after the filing of a request for continued examination under 37 CFR §1.114).
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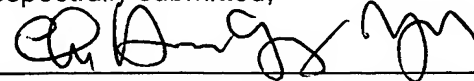
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May 16, 2005
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Respectfully submitted,


Chiahua George Yu, Attorney for Applicant(s)
Reg. No. 43,301
Tel.: (858) 793-9282; Fax: (858) 793-9501



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Application Number	10/613,513
Filing Date	July 3, 2003
First Named Inventor	LIM, Brian Y.
Art Unit	1725
Examiner Name	ELVE, Maria Alexandra
Attorney Docket Number	ATO-001.00

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				Application Number	10/613,513
				Filing Date	July 3, 2003
				First Named Inventor	LIM, Brian Y.
				Art Unit	1725
				Examiner Name	ELVE, Maria Alexandra
Sheet	2	of *	2	Attorney Docket Number	ATO-001.00

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		L.C. QIN, D. ZHOU, A.R. KRAUSS, D. M. GRUEN; "Growing Carbon Nanotubes By Microwave Plasma-Enhanced Chemical Vapor Deposition"; Appl. Phys. Lett.; June 29, 1998; pp. 3437-3439; Vol. 72, No. 26	
		DANIEL L. JEAN, CHAD E. DUTY, BRIAN T. FUHRMAN, W. JACK LACKEY; "Precision Carbon Deposition Using Pyrolytic Laser Chemical Vapor Deposition (LCVD)"; 11th Annual Solid Freeform Fabrication Symp.; Aug. 7-9, 2000; pp. 73-79 (but copy supplied is from: http://www.me.gatech.edu/Lackey/djsff2000.pdf , via: http://www.me.gatech.edu/Lackey/Biosketch/biosketch.html)	
		NATHAN R. FRANKLIN, YIMING LI, ROBERT J. CHEN, ALI JAVEY, and HONGJIE DAI; "Patterned Growth of Single Walled Carbon Nanotubes on Full 4-Inch Wafers"; Appl. Phys. Lett.; Dec. 31, 2001; pp. 4571-4573; Vol. 79, No. 27	
		F. ROHMUND and R.-E. MORJAN, G. LEDOUX and F. HUISKEN, R. ALEXANDRESCU; "Carbon Nanotube Films Grown by Laser-Assisted Chemical Vapor Deposition"; J. Vac. Sci. Technol.; May/June 2002; pp. 802-811; B 20 (3)	
		R. ALEXANDRESCU, A. CRUNTEANU, R.-E. MORJAN, I. MORJAN, F. ROHMUND, L.K. L. FALK, G. LEDOUX, F. HUISKEN; "Synthesis of Carbon Nanotubes by CO ₂ -Laser-Assisted Chemical Vapor Deposition"; Infrared Phys. Technol.; 2003; pp. 43-50; 44	

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